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Bib Data Sheet

CONFIRMATION NO. 1881

SERIAL NUMBER 09/753,662	FILING DATE 01/04/2001 RULE	CLASS 117	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 1592-0131P
APPLICANTS Shigeto Fujimura, Toda-shi, JAPAN; Toshiaki Asahi, Toda-shi, JAPAN; Kenji Sato, Toda-shi, JAPAN;				
** CONTINUING DATA *****				
** FOREIGN APPLICATIONS ***** JAPAN 2000-1675 01/07/2000 <i>NAH 1/24/02</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/15/2001				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met <i>NAH</i> Verified and <i>NAH</i> Acknowledged <i>NAH</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 1
INDEPENDENT CLAIMS 1				
ADDRESS BIRCH, STEWART, KOLASCH AND BIRCH, LLP P.O. Box 747 Falls Church, VA 22040-0747				
TITLE Process for producing compound semiconductor single crystal				
FILING FEE RECEIVED 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	